	Application No.	Applicant(s)
Notice of Allowability	, Approalie in the	Approductor
	09/897,955	KAWANO ET AL.
Notice of Anowability	Examiner	Art Unit
	Mike Qi	2871
The MAILING DATE of this communication appearance All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this a or other appropriate communication IGHTS. This application is subject	pplication. If not included on will be mailed in due course. THIS
1. This communication is responsive to the amendment of Aug. 4, 2005.		
2. The allowed claim(s) is/are <u>2-4 and 6-8</u> .		
<ul> <li>3.</li></ul>	,	
1. 🗮 Certified copies of the priority documents have been received.		
2. Certified copies of the priority documents have been received in Application No		
3. Copies of the certified copies of the priority documents have been received in this national stage application from the		
International Bureau (PCT Rule 17.2(a)).		
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application.  THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		
4. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.		
5. CORRECTED DRAWINGS (as "replacement sheets") must be submitted.		
(a) ☐ including changes required by the Notice of Draftsperson's Patent Drawing Review ( PTO-948) attached		
1)  hereto or 2)  to Paper No./Mail Date		
(b) ☐ including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date		
Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d).		
6. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.		
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Attachment(s)	5 T N " (1 ( )	D. I I. A P (DTO. 450)
1. Notice of References Cited (PTO-892)	· -	Patent Application (PTO-152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☐ Interview Summa Paper No./Mail D	Pate .
3. Information Disclosure Statements (PTO-1449 or PTO/SB/0		dment/Comment
Paper No./Mail Date  4. Examiner's Comment Regarding Requirement for Deposit	8. 🛛 Examiner's Stater	ment of Reasons for Allowance
of Biological Material	9.	

Application/Control Number: 09/897,955

Art Unit: 2871

## **DETAILED ACTION**

## **EXAMINER'S AMENDMENT**

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Mr. Eckhard H. Kuesters on Sep.6, 2005.

The application has been amended as follows:

1) The non-elected claims 9-11 have been canceled.

Application/Control Number: 09/897,955 Page 3

Art Unit: 2871

## Allowable Subject Matter

1. Claims 2-4 and 6-8 are allowed.

2. The following is an examiner's statement of reasons for allowance:

The prior art of record neither discloses nor teaches that a tandem repair pattern for a matrix array substrate in a liquid crystal display comprising various elements as claimed, more specifically, as the following;

a tandem repair circuit comprises a first, second and third connector electrodes in which the first connector electrode being comprised of a thin-width wiring portion extending from an area above the third connector electrode (bridged connector electrode) to an area above a scanning line and substantially crossing a contour of the scanning line; and a thick-width portion being connected with an end of the thin-width wiring portion and located within contours of the scanning lines as shown in Figs.1-2 [claim 2];

The closest prior art AAPA and US 5,517,341 (Kim et al) discloses a tandem repair pattern for the pixel electrode defects using first, second and third connector electrode, and using pixel overlapping gate line to form storage capacitor. However, the prior art of record do not disclose such tandem repair pattern in which the first connector electrode having thin-width portion and thick-width portion as shown in Figs.1-2 and as claimed in claim 2.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably

Art Unit: 2871

accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

3. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Mike Qi whose telephone number is (571) 272-2299. The examiner can normally be reached on M-T 8:00 am-5:00 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Robert Kim can be reached on (571) 272-2293. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Mike Qi September 6, 2005

ROBERT KIM SUPERVISORY PATENT EXAMINER